

Attorney's Docket No.: 42P17283

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Hok-Kin Choi, et al.

Examiner: Not yet assigned

Application No. 10/750,062

Art Unit: 2856

Filed: 12/30/2003

For: A METHOD TO ASSAY
SACRIFICIAL LIGHT ABSORBING
MATERIALS AND SPIN ON GLASS
MATERIALS FOR CHEMICAL ORIGIN OF
DEFECTIVITY

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being
transmitted to facsimile (703) 746-7240 addressed to
Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450 on 7/29/04 Judy L. Steinbraus

RECEIVED
CENTRAL FAX CENTER
JUL 29 2005

Commissioner For Patents
Alexandria VA 22313-1450

STATUS QUERY

Sir:

Applicant respectfully requests status of the above-referenced application. No further reply has been received from the U.S. Patent and Trademark Office subsequent to the Updated Filing Receipt as mailed 06/25/2004 from the U. S. Patent and Trademark Office (copy attached).

Authorization is hereby given to charge our Deposit Account No. 02-2666 for any charges that may be due.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 29 July 2005

12400 Wilshire Boulevard
Seventh Floor
Los Angeles, CA 90025-1026
(408) 720-8300


Suk S. Lee, Reg. No. 47,745